

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

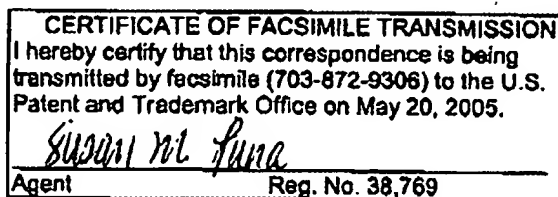
Application of

Applicant : Jigish Trivedi
Serial No. : 08/915,658
Filed : August 21, 1997
Title : LOW RESISTANCE METAL SILICIDE LOCAL
INTERCONNECTS AND METHOD OF MAKING
Docket No. : MIO 0024 PA (97-0043)
Examiner : G. Peralta
Art Unit : 2814

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Sir:

AMENDMENT AFTER FINAL REJECTION

This paper is being filed in response to the Office Action mailed April 4, 2005. Reconsideration and reexamination are respectfully requested in light of the amendments and remarks below. Entry of the amendment is respectfully requested as it is believed to place the application in condition for allowance or at least materially reduce the issues on appeal.

*Please
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JP
6/22/05*